



Attorney Docket SEL 171

AF # 2720

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Masaya Kadono et al.

Serial No.: 09/535,233

Filed: March 24, 2000

For: A Method Of Manufacturing A
Semiconductor Device

Art Unit: 2823

Examiner: W. Coleman

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 9/9/05
Signature Date

AMENDMENT J (AFTER FINAL)

Sir:

In response to the Final Rejection of June 9, 2005, please enter the following amendment in
the above-identified application: